

**CERTIFICATE OF MAILING**

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants:	Jerald P. Dykstra et al.	Examiner:	Nguyen, Lam S.
Serial No:	09/905,536	Art Unit:	2853
Filed:	July 13, 2001	Attorney Docket No. 11460-111	
Patent No.:	6,770,874 B2		
Issued:	August 3, 2004		
Title:	GAS CLUSTER ION BEAM SIZE DIAGNOSTICS AND WORKPIECE PROCESSING		

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**SUPPLEMENTAL INFORMATION DISCLOSURE**  
**STATEMENT (POST-ISSUANCE)**

Sir:

This Supplemental Information Disclosure Statement (Post-Issuance) (Form PTO/SB/08) is submitted under 37 CFR 1.97(i), including copies of the cited references. Applicants request entry into the above-referenced file of this Supplemental Information Disclosure Statement and accompanying references.

**REMARKS**

Applicants submit herewith a Supplemental Information Disclosure Statement under 37 CFR 1.97(i), including copies of the cited references. The references were cited in a Supplementary European Search report for a related patent application no more than three months prior to the filing of this information disclosure statement. No fee is believed required for entry into the file. However, if payment of a fee is deemed necessary, please charge such fee to Deposit Account 03-2410, order No. 11460-111.

The following information is presented in the event that a call may be deemed desirable by the Examiner:

DAVID W. GOMES (617) 345-3000.

Respectfully submitted,  
Jerald P. Dykstra et al., Applicants

Dated: May 31, 2007

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